

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

TAKESHITA, Mitsunori, et al.

Group Art Unit: Not Yet Assigned

Serial No.: 10/593,282

Examiner: Not Yet Assigned

Filed: September 18, 2006

P.T.O. Confirmation No.: 8499

**For. SUBSTRATE PROCESSING APPARATUS AND MANUFACTURING METHOD
FOR A SEMICONDUCTOR DEVICE**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: June 27, 2008

Sir:

This is a Preliminary Amendment for the above-captioned patent application. Please amend the above-captioned patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.